

(19) United States

(12) Patent Application Publication (10) Pub. No.: US 2024/0213299 A1 MI et al.

Jun. 27, 2024 (43) **Pub. Date:**

(54) MONOLITHIC INTEGRATION OF MULTICOLOR LIGHT EMITTING DIODES

(71) Applicant: The Regents of the University of Michigan, Ann Arbor, MI (US)

(72) Inventors: **Zetian MI**, Ann Arbor, MI (US);

Xianhe LIU, Ann Arbor, MI (US); Yi SUN, Ann Arbor, MI (US); Yakshita MALHOTRA, Ann Arbor, MI (US); Yuanpeng WU, Ann Arbor, MI (US)

18/573,969 (21) Appl. No.: (22) PCT Filed: Jun. 24, 2022

(86) PCT No.: PCT/US2022/034924 § 371 (c)(1),

> (2) Date: Dec. 22, 2023

Related U.S. Application Data

(60) Provisional application No. 63/215,130, filed on Jun. 25, 2021.

Publication Classification

(51) **Int. Cl.** H01L 27/15 (2006.01)

(52) U.S. Cl. CPC H01L 27/156 (2013.01)

(57)ABSTRACT

Monolithic integration of multicolor light-emitting diodes with highly spatially uniform emission wavelength are realized in a single selective area epitaxy process. Pronounced emission peaks with very narrow spectral linewidths are also achieved. The indium contents and emission colors are tuned by precisely controlling the nanowire emitter diameter and lattice constant. The emission wavelengths exhibit small variations of only a few nanometers among individual nanowire emitters over an areal region.

<u>100</u>	n+ - GaN <u>116</u>
	n - GaN <u>114</u>
	GaN Tunnel Junction <u>112</u>
	p - GaN <u>110</u>
	AlGaN Barrier Layers and InGaN Dots <u>108</u>
	n - GaN <u>106</u>
	Template <u>104</u>